

**In the specification:**

Please replace the paragraph beginning at page 1, line 4, with the following rewritten paragraph:

The following patents and/or commonly assigned patent applications are hereby incorporated herein by reference:

Patent No.	Filing Date	Issue Date	Title
5,061,049	Sept. 13, 1990	Oct. 29, 1991	Spatial Light Modulator and Method
5,331,454	Jan. 16, 1992	July 19, 1994	Low Voltage Reset Process for DMD
5,583,688	Dec. 21, 1993	Dec. 10, 1996	Multi-Level Digital Micromirror Device
<del>08/833,166</del>	<del>April 4, 1997</del>		<del>Micromechanical Device Including Time-Release Passivant</del>
<u>5,939,785</u>	<u>April 3, 1997</u>	<u>Aug. 17, 1999</u>	<u>Micromechanical Device Including Time-Release Passivant</u>
08/971,810	Nov. 17, 1997		Monolayer Lubricant for Micromachines
<del>60/xxx,xxx</del>	<del>Sept. 30, 1998</del>		<del>Surface Treatment Material Deposition and Recapture</del>
<u>09/406,386</u>	<u>Sept. 27, 1999</u>		<u>Surface Treatment Material Deposition and Recapture</u>